

Joint Secretary : Nabhiraj P Y

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Brief CV:

I am from 36th Batch Training School. Joined Accelerator Physics group in VECC in 1993. I did my Ph.D in Indian Institute of Science, Bangalore in department of Instrumentation and Applied Physics. Currently I am head of ECR ions source facilities section in VECC. My specialization is in the field of ion sources and related technologies. I have been working on ECR ion sources and RF ion sources for last 25 years. I am also specialized in ion beam lithography. Developed first time in India, the ICP ion source based high current focused ion beam system for micromachining applications. I also developed all the control systems related to the ion sources and ion beam injection line to the cyclotrons. I hope this will be sufficient.